UC – ENEL491 – Journal Club

Integrated Membrane-Free Thermal Flow Sensor for Silicon-on-Glass Microfluidics

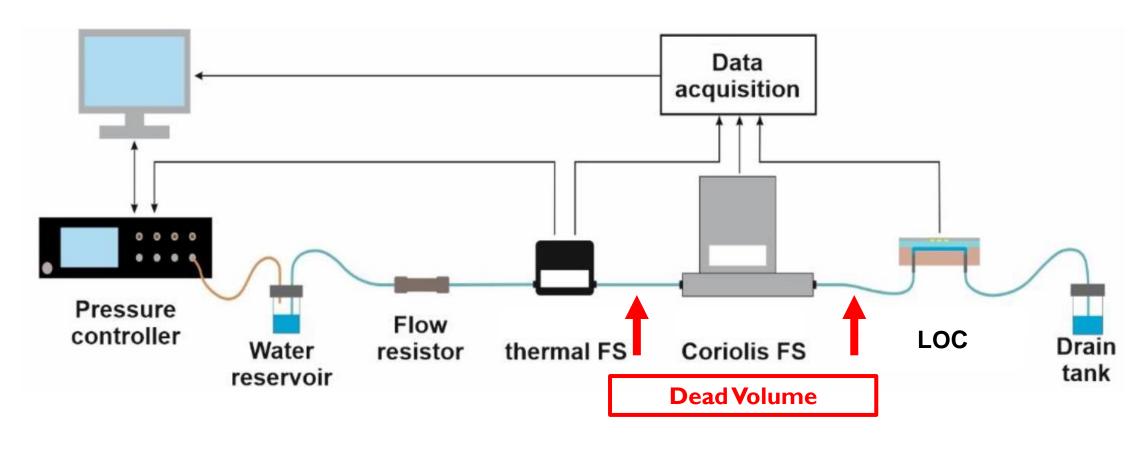
Presented by: Andreas Ming

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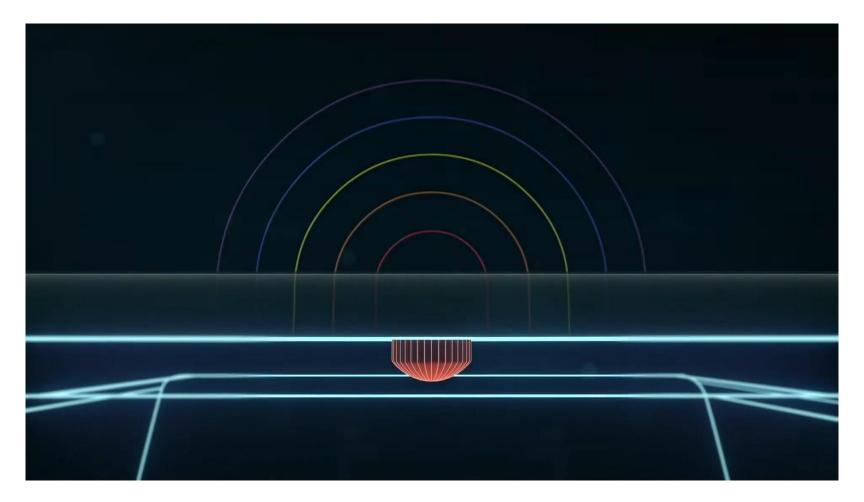
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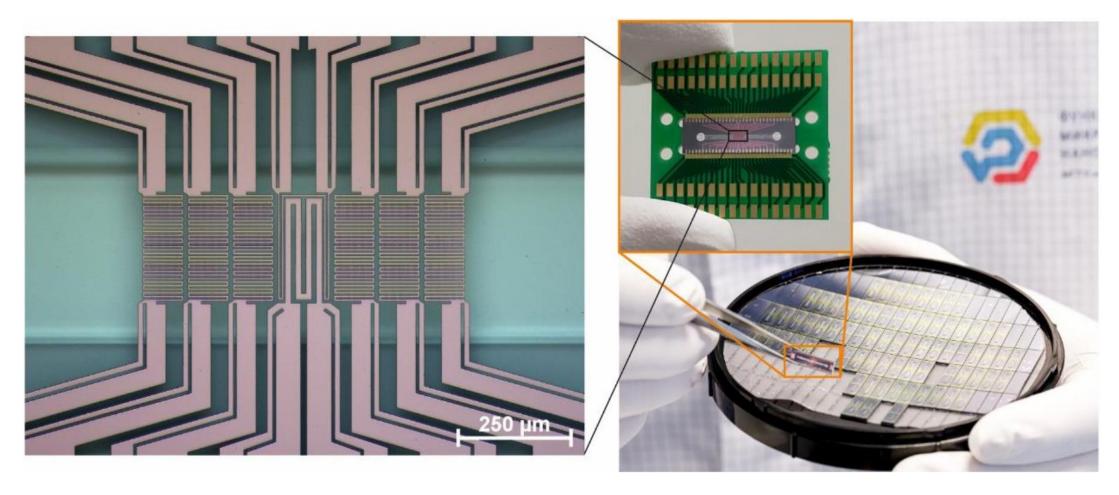
Motivation



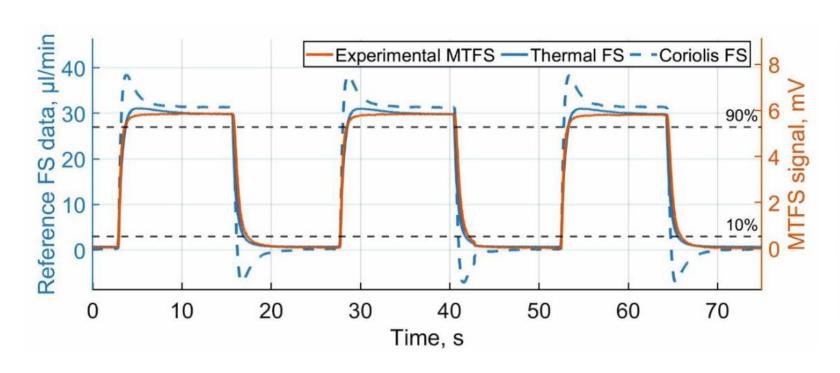
Thermal Flow Sensor Working Principle

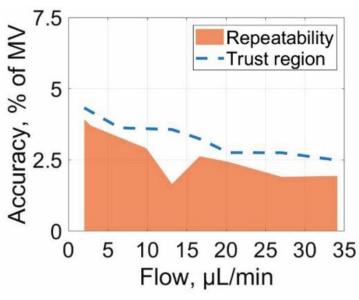


Thermal Flow Sensor Fabrication



Thermal Flow Sensor Measurements





Summary

- Fully biocompatible chip-integrated thermal flow sensor
- Fabrication within same technology cycle as microfluidic channel
- Error of less than 5% within the range of 2-30µL min-1
- Contribution towards a complete Lab-on-a-Chip